Process

Analysis Sol



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MultiGas™ 2030 CEM-Cert

GAS ANALYZER FOR CONTINUOUS EMISSIONS MONITORING

The MultiGas™ 2030 CEM-Cert is an FTIR-based gas analyzer designed for integration with complete continuous emissions monitoring systems (CEMS) to measure emissions from stationary sources such as waste incinerators, power plants and cement kilns. This analyzer is the core technology used in the TÜV and MCERTS certified MGS300 system produced by MKS Instruments.

The MultiGas 2030 instrument is capable of directly analyzing hot, wet effluent gas streams without the need for sample pre-treatment. Owing to its high resolution FTIR technology (0.5 cm⁻¹) the MultiGas 2030 CEM-Cert is capable of monitoring multiple gas components over a wide range of compositions with minimal cross-interference effects from either water (up to 40%) or other potentially interfering species. Furthermore, by using permanently stored internal reference calibration spectra, the need for costly calibration gas mixtures is all but eliminated.

Features & Benefits

- Integral component of the TÜV & MCERTS certified MGS300 – proven capability to meet the DIN EN 15267-3 standard
- Single FTIR analyzer measures main target emission species including: NO, NO₂, N₂O, SO₂, CO, CO₂, CH₄, HCI, HF, NH₃ and H₂O – no additional analyzers required for these components
- Direct analysis of effluent streams containing up to 40% water – no sample preparation required
- Permanent reference calibration spectra

 all but eliminates the need for costly calibration gas cylinders
- Patented, linearized detector response ensures all instruments maintain the same calibration and can use the same reference calibration spectra

- Frequency and resolution diagnostics ensure instrument response, and therefore calibration, is maintained for maximum accuracy
- Heated gas cell with automatic temperature and pressure compensation
 - maximizes accuracy performance and eliminates sample component condensation
- Continuous monitoring capability with rapid response to changes in the sample composition - complies with t90 performance requirements
- Software with several communication protocol options for interfacing the MultiGas 2030 with a CEMS control platform – flexible system integration
- Easy to integrate, install and maintain low cost of ownership

Description (cont'd)

The MultiGas 2030 analyzer is made up of a 2102 Process FTIR spectrometer, a patented, high-optical-throughput gas cell and a long wavelength, thermoelectrically (TE) cooled detector. Also included is the MG2000 software platform which offers several communication protocol options for interfacing to CEMS control systems.

The MultiGas 2030 instrument is housed in a rugged 19-inch rack mount chassis for convenient integration with most CEMS enclosures. The analyzer is easy to maintain and has a low cost of ownership (COO).

Applications

The MultiGas 2030 CEM-Cert is designed for integration with complete continuous emissions monitoring systems to measure gaseous emissions from stationary sources such as:

- · Waste incinerators
- · Power plants
- · Cement kilns
- · Large combustion plants
- · Turbine engines

Certification

The MultiGas 2030 CEM-Cert is the core technology used in the TÜV and MCERTS certified MGS300 system produced by MKS Instruments. MGS300 system certification was achieved in compliance with the DIN EN 15267-3 standard, which relates to automated measuring systems for the monitoring of emissions from stationary sources.

Performance

The TÜV and MCERTS "certification" and "supplementary" ranges achieved for the different gas components are shown in the table below. Estimated detection limits are also provided and calculated as three times the standard deviation in 25% water.

Gas Component	Certification Range	Supplementary Range 1	Supplementary Range 2	Detection Limit
NH ₃	0-10 mg/m ³	0-75 mg/m ³	_	0.35ppm
CO	0-75 mg/m ³	0-300 mg/m ³	0-1500 mg/m ³	0.50ppm
SO ₂	0-75 mg/m ³	0-300 mg/m ³	0-2000 mg/m ³	0.60ppm
NO	0-200 mg/m ³	0-400 mg/m ³	0-1500 mg/m ³	0.50ppm
NO ₂	0-50 mg/m ³	0-100 mg/m ³	0-1000 mg/m ³	0.40ppm
HCI	0-15 mg/m ³	0-90 mg/m ³	0-200 mg/m ³	0.20ppm
HF	0-3 mg/m ³	0-10 mg/m ³		0.25ppm
CH ₄	0-15 mg/m ³	0-50 mg/m ³	0-500 mg/m ³	0.30ppm
CO ₂	0-25%	_	_	0.025%
H ₂ O	0-40%	_	_	0.25%
N ₂ O	0-50 mg/m ³	0-100 mg/m ³	0-500 mg/m ³	0.10ppm

Gas Components and Ranges —

Addressed by the TÜV & MCERTS certified MGS300 system



Specifications

Analyzer

Measurement Technique FTIR Spectrometry

Gases and Ranges Refer to the Gas Components and Ranges Table

Spectral Resolution 0.5 cm⁻¹
Scan Time 60 seconds

Infrared Source Silicon Carbide @ 1200°C

Reference Helium Neon Laser (15798.2 cm⁻¹)

Detector Thermoelectrically (TE) cooled MCT (Hg Cd Te)

Certified Temperature Range +5°C to +40°C

Purge Pressure 20 psig (1.5 bar) max.

Spectrometer Purge Flow

0.2 L/min of dry N₂ or CO₂ free clean, dry air with dewpoint below -70°C

Optics Purge Flow

0.2 L/min of dry N₂ or CO₂ free clean, dry air with dewpoint below -70°C

Purge Connection ¼" Swagelok® quick connect

Pressure Transducer MKS Baratron® capacitance manometer

Dimensions 444.5 W x 317.5 H x 647.7 D mm (17.5"W x 12.5"H x 25.5"D)

Enclosure 19" Rack mount chassis

Power 230VAC/50Hz or 115VAC/60Hz, 3 amps

Weight 50 kg (110 lbs.)

Compliance CE

Laser Safety Class 1 laser product contains a Class 3R laser with continuous wave output at 633 nm

Sampling Parameters

Sample Temperature 191 $^{\circ}$ C
Sample Flow 1.6 L/min
Sample Pressure 1 atm ± 0.05

Gas Cell

Construction Ni coated Al

 ${\rm Mirrors} \qquad \qquad {\rm Ni~plated~Al~substrate~with~corrosion~resistant~MgF}_2~{\rm coated~gold~surface}$

Path Length 5.11m

Fittings ¼" threaded Swagelok®

Tubing Heated ¼" stainless steel

Computer Requirements and Communication Options

Computer Requirements Desktop or notebook (1024 x 768 resolution)

Intel Pentium® PC, Microsoft® Windows® XP or Windows® 7 OS

Minimum Specification Intel Pentium III, 850 MHz, Microsoft Windows XP, 256MB

Computer/FTIR Communications RJ-45 Crossover Ethernet

Communication Protocol Options TOOLweb® (HTML based), OPC, Modbus TCP/IP



Ordering Information

Ordering Code

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MultiGas 2030 CEM-Cert	Model No. 2030D-29805	
Spares and Accessories		
Gas Cell Window Kit (BaF ₂ /Viton®)	133525-G3	
Filter Assembly	134838-G1	
Replacement HeNe Laser	001-8446	
Replacement IR Source Fan	001-8498	



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